




FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT		Atty. Docket		Application No.			
		OHG 135		10/660,490			
		Applicant Makoto TERUI					
		Filing Date November 28, 2003		Group 2812			
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
<i>CA</i>	AA	US 5,932,493	08/03/99	AKATSU et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation
<i>CA</i>	AI	7-275813	10/24/95	JAPAN			Abstract and Translation
	AJ						
	AK						
	AL						
	AM						
	AN						
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
	AO						
Examiner <i>C. J. [Signature]</i>					Date Considered <i>4/5/05</i>		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT 	Atty. Docket: OHG-125	Application No.: 10/660,490
	Applicant: Noriko TOMITA et al.	
	Filing Date: September 12, 2003	Group Art Unit: 2812

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
<i>COL</i>	AA	6,165,956	12/26/00	Zhang et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Trans - lation
<i>COL</i>	AI	2001-521285	06/11/01	Japan			No
	AJ						
	AK						
	AL						
	AM						

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

	AN	
	AO	

Examiner

[Signature]

Date Considered

4/5/05

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	Atty. Docket: OHG-135	Application No.: Not yet assigned
	Applicant: Noriko TOMITA et al.	
	Filing Date: September 12, 2003	Group Art Unit: Not yet assigned

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation
	AI						
	AJ						
	AK						
	AL						
	AM						

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

<i>Cal</i>	AN	"Chemical Contamination in the semiconductor process environment and counter-measures therefor". Realize Inc., pp. 268-269 (page 6 of the specification)
<i>Cal</i>	AO	"The current status of contamination in the ULSI fabricating". Realize Inc., pp. 378-383

Examiner <i>[Signature]</i>	Date Considered <i>4/5/05</i>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.